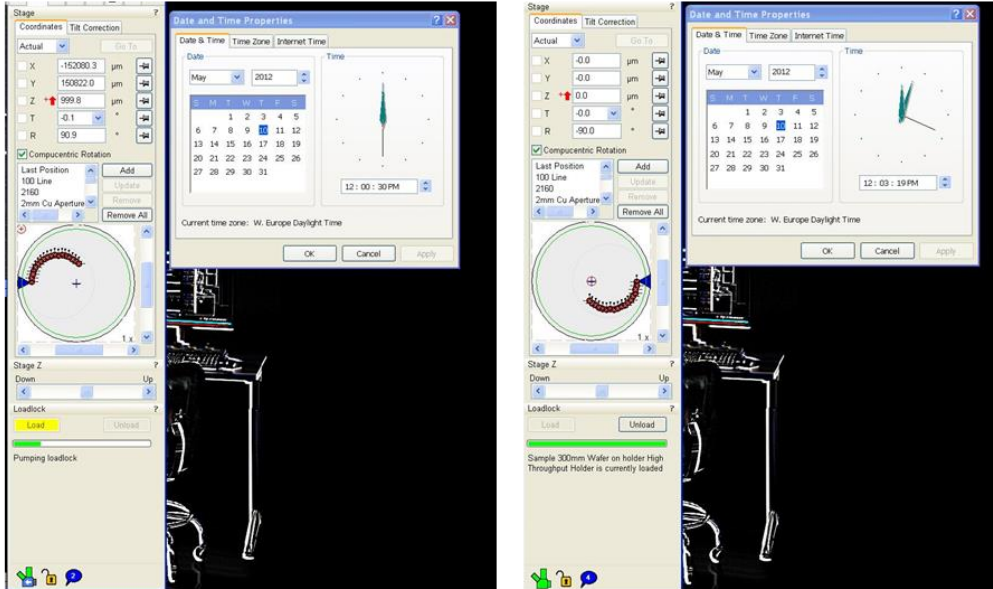


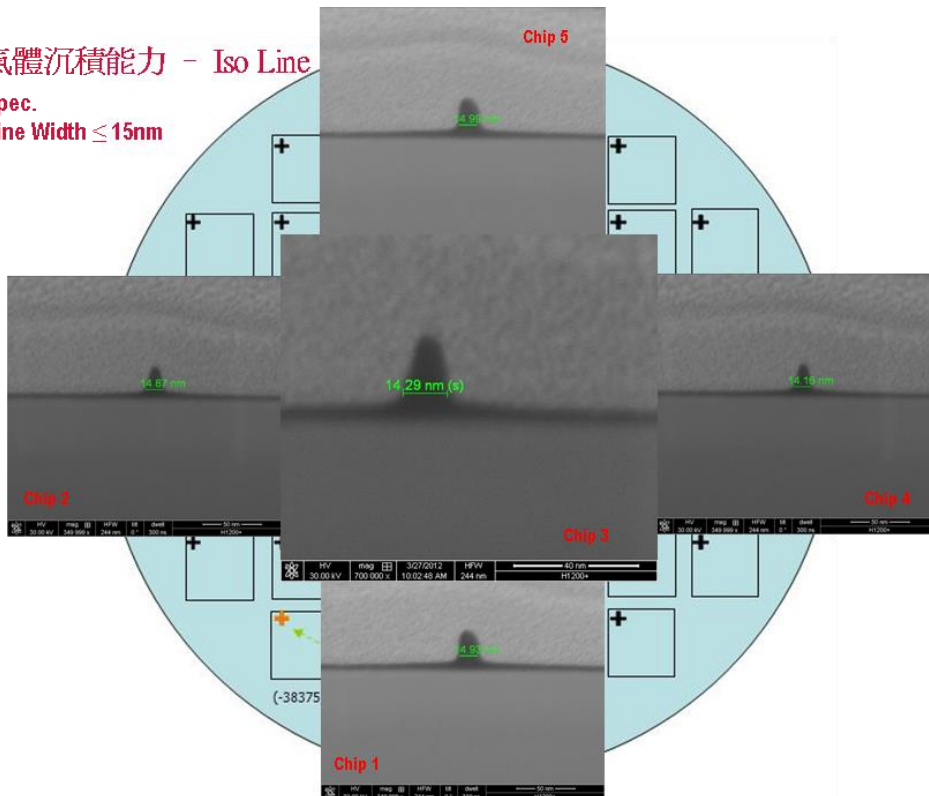
聚焦電子束系統技術資料

樣品腔體載入時間 $\leq 5\text{mins}$

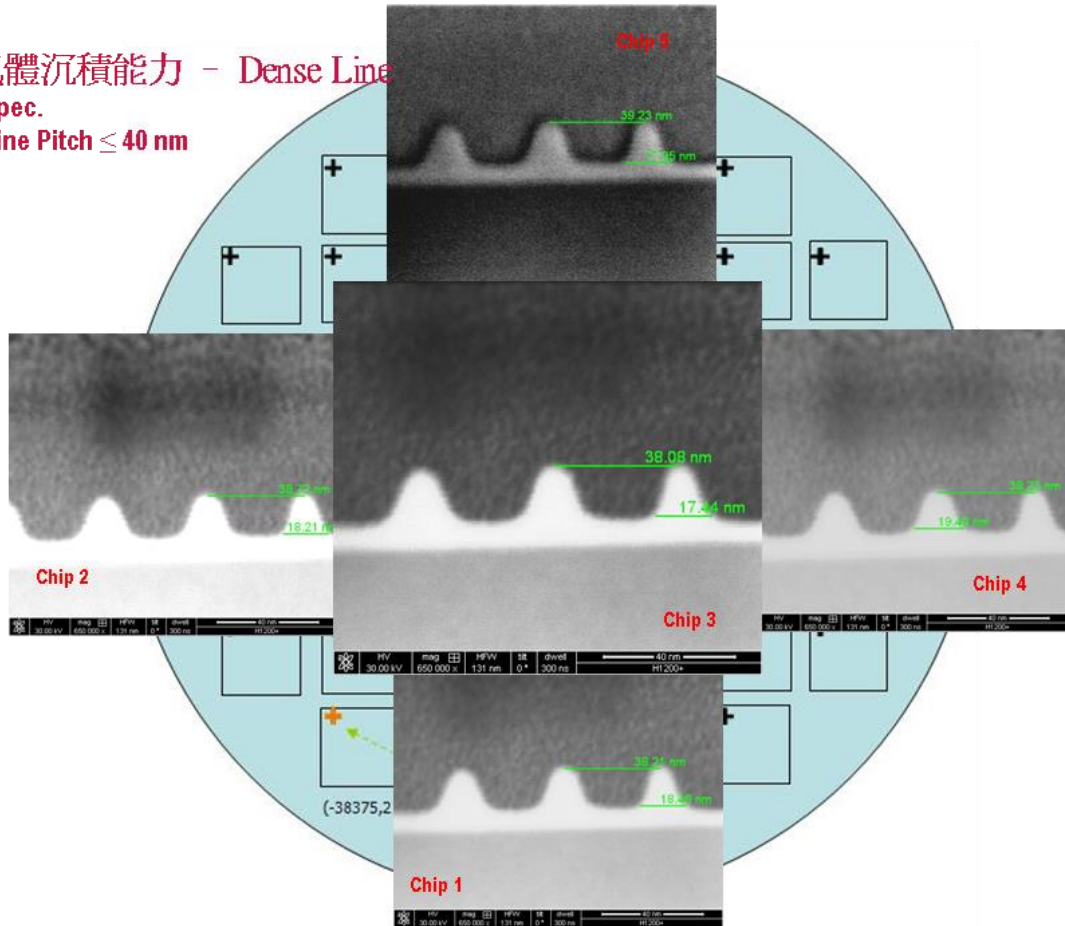
Total loading time 02:41 < 5mins



- 氣體沉積能力 - Iso Line Spec.
Line Width $\leq 15\text{nm}$

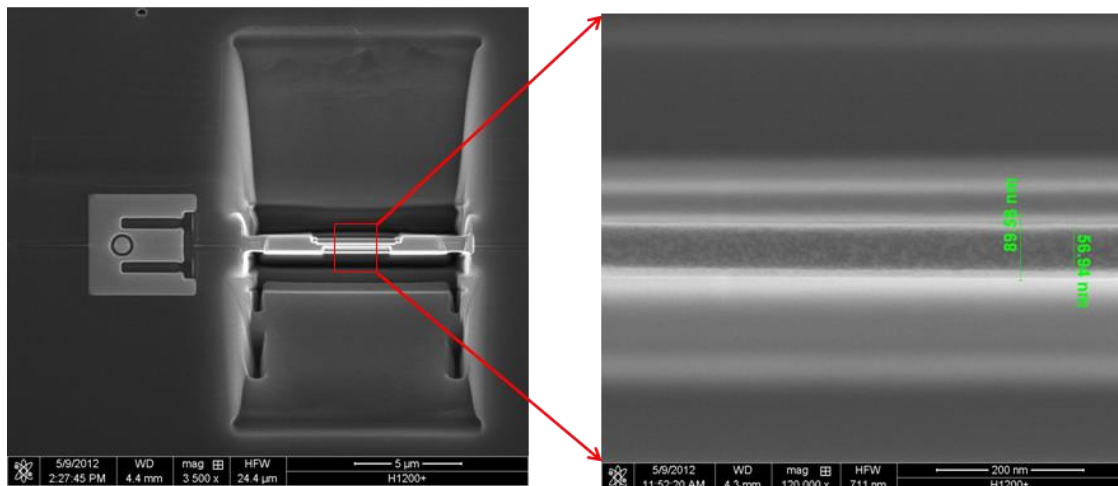


- 氣體沉積能力 - Dense Line
Spec.
Line Pitch ≤ 40 nm



- 自動切割TEM厚度與精準度

Spec.
厚度 ≤ 100 nm
精確度 ≤ 30 nm



Thickness measurement: $(89.85 + 56.94) / 2 = 73.395$ nm < 100 nm